



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.09/234,233
Confirmation No.6381
Filing Date January 20, 1999
Inventor Weimin Li et al.
Assignee Micron Technology, Inc.
Group Art Unit 2818
Examiner Dung Anh Le
Customer No.021567
Attorney's Docket No.MI22-1035
Title: Semiconductor Processing Methods

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Reference -See Attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

This Supplemental Information Disclosure Statement is being filed together with the filing of a Request for Continued Examination (RCE) Application. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 18 Jul 2006

By: _____

James E Lake
Reg. No. 44,854

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1035	SERIAL NO. 09/234,233
<div style="position: relative; height: 100px;"> <div style="position: absolute; top: 0; left: 0; width: 100%; height: 100%; border: 1px solid black; border-radius: 50%; text-align: center; line-height: 100px; font-size: 24px; font-weight: bold;"> OIPE IAP79 JUL 18 2006 PATENT & TRADEMARK OFFICE </div> </div>				LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)	
				APPLICANT: Weimin Li et al.	
				FILING DATE January 20, 1999	GROUP 2818

U.S. PATENT DOCUMENTS							
*Examiner's Initials	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
AA	6,727,173	04/2004	Sandhu et al.				
AB	6,114,736	09/2000	Balasubra et al.				
AC	6,208,004	03/2001	Cunningham				
AD	6,118,163	09/2000	Gardner et al.				
AE	5,796,151	08/1998	Hsu et al.				
AF	5,276,347	01/1994	Wei et al.				
AG	5,759,746	06/1998	Azuma et al.				
AH							
AI							

FOREIGN PATENT DOCUMENTS							
Document Number	Date	Country	Class	Subclass	Translation		
					Yes	No	
AJ							
AK							
AL							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
	AM		
	AN		
	AO		

EXAMINER	DATE CONSIDERED
----------	-----------------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.